

Practitioner's Docket No.: 782_215

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Hideyoshi TSURUTA, Satoru YAMADA, Kiyoshi NASHIMOTO and Naoki MIYAZAKI

Ser. No.: 10/057,804

Group Art Unit: 2831

Filed: January 25, 2002

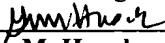
Examiner: Eric W. Thomas

Confirmation No.: 9257

For: ELECTROSTATIC CHUCK AND SUBSTRATE PROCESSING APPARATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Gina M. Husak

AMENDMENT

Sir:

In response to the Office Action mailed July 16, 2003, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 6 of this paper.

Amendments to the Abstract are shown on page 8 of this paper

Remarks/Arguments begin on page 9 of this paper.

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